

<b>Notice of References Cited</b>	Application/Control No. 10/810,784	Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner Sylvia R. MacArthur	Art Unit 1763	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,165,058	12-2000	Zuniga et al.	451/287
*	B	US-2004/0005842	01-2004	Chen et al.	451/41
*	C	US-6,406,361	06-2002	Zuniga et al.	451/287
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	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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